

Docket No.: 2328-062

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	
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Inventor(s): DHINDSA, Rajinder et al.	:	Confirmation No.8414
	:	
U.S. Patent Application No. 10/645,665	:	Group Art Unit: 2821
	:	
Filed: August 22, 2003	:	Examiner: TUNG X LE
For: MULTIPLE FREQUENCY PLASMA ETCH REACTOR		

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449.

This Information Disclosure Statement is being filed under Rule 37 CFR 1.97(i), wherein applicants are submitting an IDS before the grant of a patent to be placed in the file but not considered by the Patent Office. No certification or fees are deemed necessary.

Respectfully submitted,

LOWE HAUPTMAN HAM & BERNER, LLP

/Allan M. Lowe/

Allan M. Lowe
Registration No. 19,641

1700 Diagonal Road, Suite 300
Alexandria, Virginia 22314
(703) 684-1111 AML/cjf
Facsimile: (703) 518-5499
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